Application/Control No.	Applicant(s)/Patent under Reexamination	
09/879,583	WIPFEL ET AL.	
Examiner	Art Unit	
Vemane M. Gerezgiher	2144	

	SEARCHED		
Class	Subclass	Date	Examiner
709	.208,213	4/14/2005	YMG
709	223,224	4/14/2005	YMG.
709	226,229	4/14/2005	YMG
714	4,37,43	4/14/2005	YMG
709	201,220	4/15/2005	YMG
709	223,248	4/15/2005	YMG
714	15	4/15/2005	YMG
	•		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
709	224	4/14/2005	YMG
709	201,248	4/15/2005	YMG
714	4, 15	4/15/2005	YMG

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Updated East Keyword search	4/14/2005	YMG
NPL (IEEE, CiteSeer, Google)	4/15/2005	YMG
Consulted with Primary Examiner Marc D. Thompson	2/23/2005	YMG
×		
•		